

# Search Notes



Application/Control No.

10/624,254

Examiner

Jennifer C. McNeil

Applicant(s)/Patent under  
Reexamination

KIM ET AL.

Art Unit

1775

## SEARCHED

Class	Subclass	Date	Examiner
408	632 328 697	12/5	JW
	699 701		
	702		
410	241R		
427	453,454		
	455,456		

## INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
East	12/5	JW
Inventor search	12/5	JW
NPL	12/5	JW